



Image B

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Attn: ISSUE BRANCH**  
Akira FUKUNAGA et al. : **Confirmation No. 8643**  
Serial No. 09/994,755 ✓ : [Group Art Unit 1723  
Filed November 28, 2001 : Examiner E. Therkorn]

PLATING APPARATUS AND METHOD OF :  
MANAGING PLATING LIQUID COMPOSITION

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

**REQUEST FOR ACKNOWLEDGMENT OF CLAIM OF PRIORITY**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Notice of Allowability dated November 25, 2003, Applicants respectfully request that the Examiner acknowledge perfection of the Applicants' claim for foreign priority under 35 USC §119 in the above-referenced U.S. patent application.

Applicants filed a claimed priority on February 1, 2002. A copy of the Claim of Priority is submitted herewith.

As a result, it is submitted that the Applicants' claim for foreign priority has been perfected, and acknowledgment of such is respectfully requested.

Respectfully submitted,

Akira FUKUNAGA et al.

By

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December 2, 2003



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Confirmation No. 8643

Akira FUKUNAGA et al. : Docket No. 2001\_1767A

Serial No. 09/994,755 : Group Art Unit 1723

Filed November 28, 2001 :

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ACCOUNT NO. 23-0975

PLATING APPARATUS AND METHOD OF  
MANAGING PLATING LIQUID COMPOSITION

CLAIM OF PRIORITY UNDER 35 USC 119

Assistant Commissioner for Patents,  
Washington, DC 20231

Sir:

Applicants in the above-entitled application hereby claim the date of priority under the International Convention of Japanese Patent Application No. 2000-362559, filed November 29, 2000, as acknowledged in the Declaration of this application.

A certified copy of said Japanese Patent Application is submitted herewith.

Respectfully submitted,

Akira FUKUNAGA et al.

By Michael S. Huppert  
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February 1, 2002



日 本 国 特 許 庁  
JAPAN PATENT OFFICE

別紙添付の書類に記載されている事項は下記の出願書類に記載されている事項と同一であることを証明する。

This is to certify that the annexed is a true copy of the following application as filed with this Office

出 願 年 月 日

Date of Application:

2000年11月29日

出 願 番 号

Application Number:

特願2000-362559

出 願 人

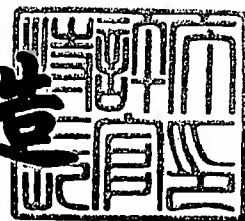
Applicant(s):

株式会社荏原製作所

2001年11月 9日

特 許 庁 長 官  
Commissioner,  
Japan Patent Office

及 川 耕 造



出証番号 出証特2001-3099207